

AMENDMENTS TO THE CLAIMS

1. (Currently Amended) An apparatus comprising:

a substrate having at least one aperture having a tapered portion with a top diameter greater than a bottom diameter and wherein the tapered portion of the aperture transitions into a cylindrical portion having a diameter equal to said bottom diameter of said tapered portion;

cross-linkers attached to ~~the~~ an inner walls of said aperture; and

a macro-cyclic ring, having a diameter substantially the same as the diameter of the cylindrical portion of said aperture, attached at or near the circumference of one end of the cylindrical portion of said aperture.
2. (Original) The apparatus of claim 1, wherein the substrate is chosen from the group consisting of glass, carbon, polymeric materials, and semiconductors.
3. (Original) The apparatus of claim 1, wherein the macro-cyclic ring has a rigid phenylethynyl backbone.
4. (Original) The apparatus of claim 1, wherein a biological or chemical probe is attached to the macro-cyclic ring such that the biological or chemical probe extends into and rests between at least a portion of the surfaces of the inner walls of the cylindrical portion of said aperture.

5. (Original) The apparatus of claim 4, wherein the biological probe comprises a single strand sequence of DNA.
6. (Currently Amended) The apparatus of claim 1, wherein the substrate comprises a layer of Silicon Nitride, a layer of Silicon, a layer of Silicon Oxide, a layer of Silicon,
~~On Insulator (SOI) wafer~~ and a layer of Silicon Nitride.
7. (Currently Amended) An apparatus comprising:
a substrate having at least one aperture having a tapered portion with a top diameter greater than a bottom diameter and wherein the tapered portion of the aperture transitions into a cylindrical portion having a diameter equal to said bottom diameter of said tapered portion;
cross-linkers attached to ~~the~~ an inner walls of said aperture; and
antibodies or chemical functional groups deposited around the inner walls of the aperture or around the circumference of one end of said aperture.
8. (Original) The apparatus of claim 7, wherein the substrate is chosen from the group consisting of glass, carbon, polymeric materials, and semiconductors.
9. (Currently Amended) The apparatus of claim 7, wherein the substrate comprises a layer of Silicon Nitride, a layer of Silicon, a layer of Silicon Oxide, a layer of Silicon,
~~On Insulator (SOI) wafer~~ and a layer of Silicon Nitride.

10. (Withdrawn) A method comprising:

providing a substrate having at least one aperture having a tapered portion with a top diameter greater than the bottom diameter and wherein the tapered portion of the aperture transitions into a cylindrical portion having a diameter equal to said bottom diameter of said tapered portion; and

functionalizing said aperture to bind to a specific biological or chemical moiety.

11. (Withdrawn) A method comprising:

providing a substrate having at least one aperture having a tapered portion with a top diameter greater than the bottom diameter and wherein the tapered portion of the aperture transitions into a cylindrical portion having a diameter equal to said bottom diameter of said tapered portion, wherein said aperture is functionalized to bind to a specific biological or chemical moiety; and

passing a sample through said aperture while simultaneously measuring the variation in ionic current across the depth of said aperture.

Election/Restriction

Applicants acknowledges the Examiner's telephone inquiry of 25 April 2006 regarding election to prosecute the invention of Group I, claims 1-9. The Applicants formally elects, without traverse, to prosecute the invention of Group I, claims 1-9. Applicants have withdrawn from further consideration claims 10 and 11 as being drawn to a non-elected invention.